

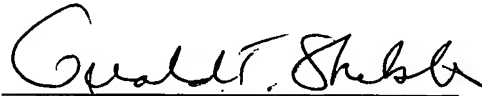


ITW

PATENT  
Attorney Docket No. 1110/90738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application	)	Confirmation No.: 1669
	)	
Applicants: Satoshi Komiya et al.	)	<i>I hereby certify that this correspondence is</i>
	)	<i>being deposited with the United Postal</i>
Serial No.: 10/679,031	)	<i>Service as first class mail in an envelope</i>
	)	<i>addressed to: Mail Stop AMENDMENT,</i>
Filed: October 3, 2003	)	<i>Commissioner for Patents, P.O. Box 1450,</i>
	)	<i>Alexandria, Virginia 22313-1450.</i>
For: EPITAXIAL SILICON WAFER	)	
	)	<u>June 22, 2007</u>
Examiner: Matthew J. Song	)	
	)	
Art Unit: 1765	)	

  
Gerald T. Shekleton, Reg. No. 27,466

AMENDMENT

Mail Stop: AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of February 23, 2007, has been carefully reviewed and the following amendments and remarks are made in response thereto.